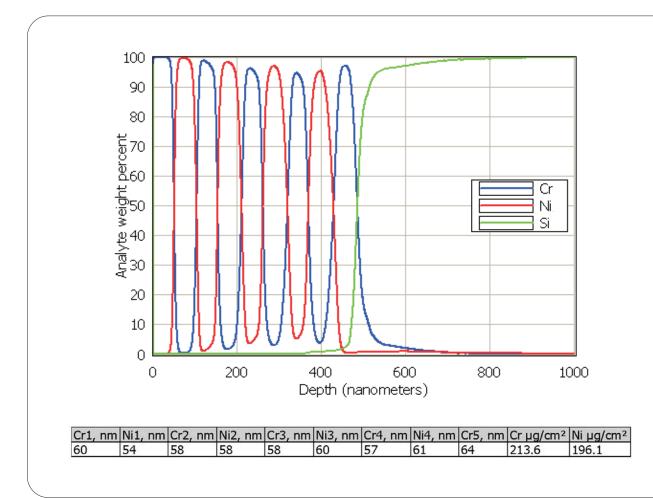
Quantitative Depth Profile (QDP) Analysis of NIST 2135c - Ni/Cr Thin Film Depth Profile Standard



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GDS-850A analysis of thin film standard certifed at Cr = 206.3 \pm 13.8 µg/cm² and Ni = 197.4 \pm 9.6 µg/cm² with nominal layer thicknesses of Ni = 57 nm and Cr = 56 nm.

Parameters

Grimm-Style RF 4 mm Lamp 30 mA, 1000 V Surface layers <10 s, 1000/s Total analysis 30 s

For questions on this analysis e-mail us at: info@leco.com

For a complete listing of snapshots and performance notes visit us on the web at <u>www.leco.com</u> in the Spectroscopy section of the Applications Library.

